

10/594980

IAP2 Rec'd PCT/PTO 29 SEP 2006

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
HIROFUMI TAKIKAWA et al.  
International Appl. No.: PCT/JP2005/002479  
International Appl. Date: 17 February 2005  
For: POWER SUPPLY CIRCUIT FOR  
PLASMA GENERATION, PLASMA  
GENERATING APPARATUS,  
PLASMA PROCESSING  
APPARATUS AND PLASMA  
PROCESSED OBJECT

Art Unit: --  
Examiner: --

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that a Preliminary Amendment be entered as follows: